Role of abrasive material on micro-abrasion wear tests

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ABSTRACT

Micro-abrasion wear tests with ball-cratering configuration are widely used. Sources of variability are already studied by different authors and conditions for testing are parameterized by BS EN 1071-6: 2007 standard which refers silicon carbide as abrasive. However, the use of other abrasives is possible and allowed. In this work, ball-cratering wear tests were performed using four different abrasive particles of three dissimilar materials: diamond, alumina and silicon carbide. Tests were carried out under the same conditions on a steel plate provided with TiB₂ hard coating. For each abrasive, five different test durations were used allowing understanding the initial wear phenomena. Composition and shape of abrasive particles were investigated by SEM and EDS. Scar areas were observed by optical and electronic microscopy in order to understand the wear effects caused by each of them. Scar geometry and grooves were analyzed and compared. Wear coefficient was calculated for each situation. It was observed that diamond particles produce well-defined and circular wear scars. Different silicon carbide particles presented dissimilar results as consequence of distinct particle shape and size distribution.

Keywords

Micro-abrasion, Ball-cratering, TiB2 hard coating, Abrasive particles, Wear tests, Abrasive materials

1. Introduction

In the last decade, micro-abrasion wear tests using ball cratering configuration has been widely used in order to characterize wearbehavior of thin hard coatings. Initially, this configuration was used only for film thickness measurement but it was adapted to wear studies. This wear test takes advantage over others because coating thickness constrains the volume or depth of material that can be removed before the coating is perforated [1]. Furthermore, this test is quick, convenient, can be performed on small samples and uses relatively inexpensive equipment [2]. Otherwise, reliability and reproducible measurements [3] ensure that this wear test configuration meets the requirements sought by investigators, if test conditions used are the same. However, wear rates and wear mechanisms can differ significantly when test conditions change, as normal load or sliding speed [4,5]. Authors refer [3] that two wear modes can be achieved during micro-abrasion wear tests: 'three-body' abrasion and 'two-body' abrasion. The wear mode can be changed adjusting the load or selecting other abrasive particles [6], the abrasive content in the slurry [7] and the ball surface condition [8]. Concerning the ball surface condition, Stachowiak

et al. [9] referred that soft materials were more affected by ball surface roughness than harder materials. Adachi and Hutchings [10] proposed critical conditions for the transition from 'three-body' to 'two-body', allowing predicting the wear mode in practical tests.

Many efforts has been done in order to establish the best wear test parameters and study its influence in the results [2,10–14], which subsequently gave rise to BS-EN 1071-6: 2007 standard. Before this, many devoted authors have compiled a great number of testing results in order to validate the micro-abrasion wear test [15]. This standard recommends SiC F1200 as abrasive particles, but does not restrict the use of other abrasives or grain sizes, since less than 5 μ m. Before the standard publication, other author made some studies in order to investigate the influence of grain size in micro-abrasion wear tests [9,16].

Some authors [9,10,12,16,17] recognize that particles shape strongly influences the particle motion in the contact. However, abrasive particles material also plays an important role in the micro-abrasion process. Furthermore, due to coating hardness, some works could not use silicon carbide or alumina [18,19].

Schiffmann et al. tested different slurries in free ball-cratering configuration, referring that the solution of Al_2O_3 in glycerin is more suitable for non-perforating tests [14]. It should be taken into account that, if hardness of abrasive particles is to much higher than the coating to be tested, crater depth increases substantially, facilitating abrasive particles entrainment, contributing to non-linearity

Table 1 Chemical composition of CK45 steel (%wt)

С	Mn	Si	Cr	Мо	Ni	Р	S
0.44%	0.53%	0.14%	0.044%	0.005%	0.047%	0.013%	0.02%

of the results [9]. Abrasive particles shape also takes an important role in this process.

In this work, some different abrasive materials were investigated in order to understand the different action of each one. Particleshapeand grainsize were analyzed. Using the same coating, wear coefficient was calculated for each situation.

2. Experimental details

2.1. Samples preparation

In order to carry out this work, square samples of 25 mm \times 25 mm \times 2 mm of CK45 hot rolled steel were cut. The steel chemical composition can be observed in Table 1. Hardness of the substrates was measured using an EMCOM4U 025 Universal Hardness Tester was 205HBW 2.5/187.5/5. Samples were cut, milled, ground and mechanically polished with 3 µm diamond powder during 15 min in order to obtain smooth sample surfaces. At this point, surface morphology and roughness were analyzed by Atomic Force Microscopy (AFM) technique, using VEECO Multimode equipment (7 nm tip radius) provided with NanoScope 6.13 software. Two different analysis areas were used: 10 µm × 10 µm and 50 µm × 50 µm. Arithmetic mean roughness and maximum roughness obtained by these analyses were $R_a = 0.0121$ µm and $R_t = 0.0684$ µm, respectively.

2.2. Coating process

Prior to deposition, samples were cleaned in an ultrasonic bath during 20 min. Hereafter, samples have been assembled in the PVD machine holder. Before deposition, sputter-cleaning process was done, in order to make the surface free of contaminants. Coating process was carried out in a CemeCon CC800/9ML PVD Magnetron Sputtering system, using the unbalanced magnetron sputtering technique, provided with four targets of TiB₂alloy. Deposition was assisted by Ar⁺. Deposition parameters used in the deposition are the following: substrate temperature of 450 °C, pressure inside the reactor, 500 mbar, current intensity in the targets, 20 A, time deposition, 210 min and rotational holder speed, 1 revolution per minute.

2.3. Coating morphological characterization

After deposition, one of the samples was cut in the reverse side of the coating and mechanically cracked, in order to observe its structure. Other sample was subject to metallurgical preparation, allowing accurately measuring the film thickness. In order to carry out these observations, a FEI Quanta 400FEG scanning electron microscope (SEM) provided with an EDAX Genesis X-ray spectroscope (EDS) was used. Confirming the SEM morphological analysis, atomic force microscopy (AFM) analyses were made using the equipment and software above referred. 10 μm 10 μm and

50 μm×50 μm AFM analyses were made, using the tapping mode. Hardness measurements were carried out in a micro-hardness

Hardness measurements were carried out in a micro-hardness FischerscopeTMH100equipment.Selected range load was0–50mN and the maximum load was kept constant during 30 s (avoiding creep phenomena). This equipment produces values chart that allows obtaining 'load-depth' curves, conducting to hardness and

allows obtaining 'load-depth' curves, conducting to hardness and Young's modulus values. Measurements were made using a Vickers indenter.

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Micro-abrasion test parameters.

Parameters	
Rotation speed [m s ⁻¹]	0.105
Normal load [N]	0.20
Tests duration [Rev.]	25, 50, 100, 200 and 400
Corresponding sliding distances [m]	1.96, 3.93, 7.86, 15.71, 31.42
Abrasive concentration [g ml ⁻¹]	6.4/98
Abrasive particles used	Diamond, alumina and SiC
Average grains size [µm]	1–5

2.4. Adhesion test

Rockwell indentation tests were made in order to verify the adhesion between coating and substrate. These tests were done in an EMCOM4U Universal Hardness Tester using 49N (5kgf), 98N (10 kgf), 294 N (30 kgf) and 980 N (100 kgf) with diamond tip Rockwell indenter. Rockwell test procedure was carried out as specified in VDI 3198: 1991 standard. Indentations were observed using the above mentioned SEM equipment. Results were compared with illustrations and failure modes illustrated in the standard, allowing the classification of the failure pattern obtained.

2.5. Micro-abrasion tests

Characterization of wear produced by each kind of abrasive particles was done using a PLINT TE 66 micro-abrasion wear tester, using a fixed ball cratering configuration. This test uses a SAE 52100 steel ball with 25 mm diameter, acting as counter body during the wear tests, dragging over the sample coated surface the abrasive particles contained in previously prepared slurry. This ball, initially in polished state, was etched in a 10% NITAL solution during 20 s, in order to increase its surface roughness to allow better abrasive particles dragging process. Abrasive slurry is constantly dripped into the contact between the ball and the sample all over the test. As stipulated by BS EN 1071-6:2007 standard, slurry was composed by 6.4 g of abrasive particles to 98 ml of distilled water. With this concentration, grooving wear was expected. Remaining test parameters can be seen in Table 2. After each wear test, ball was changed of position, avoiding non-linear results caused by increased rough-

ness of the track drawn in the ball surface. As abrasive particles three different materials were selected:

Diamond, Al_2O_3 and SiC. Due to low film thickness, small grain abrasive particles size was chosen. Two different SiC particles were used, allowing comparing its performance in micro-abrasion wear tests: the first one classified as F1000 by FEPA (Federation of European Producers of Abrasives), with average size particles of 5.5 µm but large standard deviation and another one, F1200, with about 3.4 µm of average grain size and 1.4 µm of standard deviation. The grain size and standard deviation of the different abrasive particles used in this work is shown in Table 3.

Tests with five different durations were carried out, allowing understanding micro-abrasion evolution and failure mechanisms, before and after perforation. Then, attending the abrasivity of the diamond, runs of 25, 50, 100, 200 and 400 revolutions were established. Tests were performed three times for each duration and abrasive.

Table 3			
Abrasive	particles	grain	size

Material	Average size (µm)	Deviation (µm)		
Diamond	1.0	0.6		
Alumina	1.0	0.5		
SiC F1000	5.5	4.5		
SiC F1200	3.4	1.4		



Fig. 1. Cross-section views of TiB₂ coating showing (a) the morphology and structure and (b) the thickness of the coating.

After wear tests, craters produced were carefully analyzed by SEM, using the above referred equipment. An equivalent circle was drawn in each crater, taking into account the density of detachment events around the well-defined crater.

3. Results and discussion

Coating process results in a monolayer thin film, as can be observed in Fig. 1, with ~2.1 μm thickness and a typical texture of TiB₂ coatings. Cross-section view, obtained by SEM after mechanical cracking, allows observing that film structure is extremely homogeneous and presents a columnar orientation. Morphology of the film presents some grooves randomly dispersed, which is characteristic of the TiB₂ industrial coatings. PVD sputtering deposition rate for this type of film is less than others such as TiAlN, TiAlSiN or TiAlCrN obtained with the same parameters set. The surface natural grooves can be observed in Fig. 2, acquired using atomic force microscopy. Despite of this, the measured average mean roughness obtained by this technique was 4.06 nm and the maximum roughness was 5.24 nm, using an analyzed area of 10 μ m 10 μ m, which would be considered as very smooth surface.

Due to low film thickness, coating hardness could be accessed using extra low load in the micro-hardness tester. As well-known, indentation tests depth cannot exceed 10% of film thickness; otherwise, hardness results would be influenced by substrate. Then, indentations were produced with 50 mN normal load. Hardness value obtained was 26.82 GPa, which is lower than some values



Fig. 2. AFM 3D analysis of the TiB₂ coating morphology.

referred by other authors for the same coating. Young's modulus (*E*) registered was343.4GPa and Young's modulus reduced (*Er*) was 270.26 GPa.

Fig. 3 evince the abrasive particles morphology. As can be observed, Diamond and Al₂O₃ presents similar grain size and homogeneity, whenSiCparticles exhibit high grain size and heterogeneity. When diamond and SiC particles present irregular shape and high angularity, Al₂O₃ shows regular and smooth shape.

Fig. 4 depicts the low abrasivity of the Al₂O₃ particles. Both after 25 and 400 cycles, TiB₂ coating resists to micro-abrasion and it is clear that no film perforation can be observed, even for the longest test duration selected. After 25 cycles, worn area shows polished aspect, while after 400 cycles, deep grooves are obvious. Analyzing all the scars produced with Al₂O₃ abrasive, it is possible to conclude that the first grooves appear between 25 and 50 cycles. After that, initial smooth grooves tend to increase its depth and new smooth grooves start its formation. Low abrasivity of the Al₂O₃ particles can be attributed to its relatively low hardness and rounded shape of the particlescontour.

Fig. 5 shows the craters produced by diamond particles. In this case, perforation of the TiB₂ coating was obtained before 25 cycles. Despite this short sliding distance, the crater produced with 25 cycles yields to believe that perforation occurs after a few number of ball revolutions. Then, perforation was evident in all the tests carried out with diamond particles. Notwithstanding grain size of diamond and Al₂O₃ particles to be similar, high hardness and aggressive contour of the particles produced higher micro-abrasion. Deep grooves are perceptible and craters begin as ill-defined for low number of cycles (short sliding distance) and tend to well-defined increasing the test duration. Grooves tend to be deeper in the way out side of the abrasive particles. This phenomenon can be attributed to the concentration of abrasive particles during the contact. Observing the craters, it seems that we are in presence of a mix wear mode situation, where diamond particles had been rolled by the grooves, in a channeling process, accentuating the wear and enlarging the grooves ("three-body" wear mechanism) and some particles embedded in the ball surface that acted as "two-body" wear mechanism [3,20].

Micro-abrasion wear tests carried out with SiC F1000 abrasive particles produced irregular craters, with deep grooves welldefined. In the border of these craters, there are many film detachments. These lateral damages could be originated by large abrasive particles included in the slurry. It can be noted that this abrasive presents high heterogeneity, with some particles with



Fig. 3. Abrasive particles morphology: (a) diamond, (b) alumina, (c) SiC F1000 and (d) SiC F1200 shown with the same magnification (5000×).

Table 4

Data corresponding to micro-abrasion wear tests.

Thickness [µm]	Cycles	SN		V_c	V_s	$V_c + V_s$	SN/V_c	V_S/V_C
2,1			[mm ^o]	[mm ^o]	[mm ^o]	[mm ^o]	[N m mm °]	
AI_2O_3	25	0.49		5.39E-06				
AI_2O_3	50	0.98		2.02E - 05				
AI_2O_3	100	1.96		$3.31 \mathrm{E}{-}05$				
AI_2O_3	200	3.93		4.44E - 05				
AI_2O_3	400	7.85		1.16E - 04				
Diamond	25	0.49	2.85E - 04	$2.71 \mathrm{E}{-04}$	1.39E - 05	2.85E-04	1.81 E+03	5.11E - 02
Diamond	50	0.98	4.02E - 04	3.68E - 04	5.47E-05	4.22E - 04	2.67E+03	1.49E - 01
Diamond	100	1.96	6.24E - 04	$5.94 \mathrm{E} - 04$	2.55E - 04	8.49E - 04	3.31 E+03	4.30E - 01
Diamond	200	3.93	8.33E-04	8.48E - 04	6.58E - 04	1.51 E - 03	4.63E+03	7.76E - 01
Diamond	400	7.85	1.43E - 03	1.44E - 03	2.32E-03	3.76E-03	5.45E+03	1.61E+00
SiCF1200	25	0.49		5.82E - 04	2.42E - 04	8.24E - 04	8.43E+02	4.15E - 01
SiCF1200	50	0.98		6.74E - 04	3.62E - 04	1.04E - 03	1.46E+03	5.38E - 01
SiCF1200	100	1.96		9.41 E - 04	8.52E - 04	1.79E - 03	2.09E+03	9.05E - 01
SiCF1200	200	3.93		1.24E - 03	1.63E - 03	2.86E - 03	3.18E+03	1.32E+00
SiCF1200	400	7.85		1.62E - 03	3.02E-03	4.64E - 03	4.85E+03	1.87E+00
SiCFIOOO	25	0.49		1.10E - 03	1.23E - 03	2.33E-03	4.47E+02	1.12E+00
SiCFIOOO	50	0.98		1.22E - 03	1.58E - 03	2.80E - 03	8.05E+02	1.30E+00
SiCFIOOO	100	1.96		1.35E - 03	2.01 E-03	3.37E-03	1.45E+03	1.49E+00
SiCFIOOO	200	3.93		1.84E - 03	4.03E - 03	5.87E - 03	2.13E+03	2.19E+00
SiCFIOOO	400	7.85		2.32E-03	6.66E-03	8.98E-03	3.38E+03	2.87E+00



Fig. 4. Craters produced in the TiB₂ coating ((a) and (b)) after 25 cycles (1.96 m sliding distance) with Al₂O₃ abrasive particles and ((c) and (d)) after 400 cycles (31.42 m sliding distance) with the same abrasive, under different SEM view modes.

10 μ m. Then, craters do not present a well-defined border neither a clear slope between the inner and overall borders. In this case, inner and overall crater diameters were considered the same, for wear calculation purposes, due to natural difficulty to measure the external contour. The formation of these borders can result of the conjunction of three factors: thin film thickness, high coating hardness and large abrasive particles present in the slurry. Craters diameter using this abrasive are similar to those achieved with diamond particles. Attending that SiC hardness is lower than diamond hardness, these results can be attributed mainly to abrasive grain size. As depicted in Fig. 6, film perforation was done after a low number of cycles because, after 25 cycles, crater present high diameter and well-defined grooves. The wear process is accented for tests carried out with SiC F1000 abrasive, as referred in further discussion.

Wear tests performed with SiC F1200 originated lower crater diameters than SiC F1000. Crater borders also hold many coating detachments and present ill-defined contour, as can be observed in Fig. 7. Deep grooves are obvious in all the scars and there is a clear difficulty indiscerning the overall border, even using different SEM observation modes. Craters diameter and removed material were lower than observed with SiC F1000 in the same micro-abrasion wear test conditions. Data corresponding to wear micro-abrasion tests are presented in Table 4. The wear coefficient (k_c) and wear resistance (k_c^{-1}) related with the abrasives where coating perforation was verified, were determinate using Kusano et al. [21] methodology and nomenclature, where *S* means the sliding distance (m), *N* the normal load (N), *V*_s the substrate volume removed (mm³) and *V*_c the coating volume removed (mm³). In Fig. 8, data is plotted for the different test durations used in this work, in order to determine the average wear coefficient and wear resistance for each kind of abrasive. For Al₂O₃ abrasive, no perforation was observed and, in this case, traditional wear coefficient and wear resistance calculations were done, according to BS EN 1071-6: 2007 standard and Archard equation (k = V/(SN)).

Table 5

Ratio between hardness (coating and abrasive particles), wear resistance and wear coefficient.

$J^{-1}m^{-1}$]
-5
-4
·3
-4



Fig. 5. Craters produced in the TiB₂ coating ((a) and (b)) after 25 cycles (1.96 m sliding distance) with Diamond abrasive particles and ((c) and (d)) after 400 cycles (31.42 m sliding distance) with the same abrasive, under different SEM view modes.



Fig. 6. Craters produced in the TiB₂ coating (a) after 25 cycles (1.96 m sliding distance) with SiC F1000 abrasive particles and (b) after 400 cycles (31.42 m sliding distance) with the same abrasive.



Fig. 7. Craters produced in the TiB₂ coating (a) after 25 cycles (1.96 m sliding distance) with SiC F1200 abrasive particles and (b) after 400 cycles (31.42 m sliding distance) with the same abrasive.



Fig. 8. Wear coefficient for SiC F1000, SiC F1200 and Diamond abrasive particles.

Regarding Table 5, and relating abrasives similar grain size (Al₂O₃ and Diamond), it can be observed that wear coefficient is directly proportional to the " H_a/H " ratio, relating the abrasive harness (H_a) with the coating hardness (H). These results are in line with Hutchings work [22] but disagree with the conclusions drawn by Shipway and Hogg [17] under different conditions. Then, and attending that the same film is used for all the tests, it can be referred that the hardness is the main factor acting in the microabrasion wear system. Furthermore, the rounded shape of the alumina abrasive particles contributes, surely, to lower abrasive action than diamond particles.

When SiC abrasive particles are studied, presenting the same " H_a/H " ratio, TiB₂ coating presents lower wear resistance with SiC F1200 than SiC F1000. These results show that lower dimension of the SiC F1200 abrasive particles allows that a large number of particles take part effectively in the contact zone, increasing the micro-abrasion wear process. Large particles tend to turn around the ball, rolling sometimes between the sample surface and the ball, producing some damages in the overall border, but not participate effectively in the load carrying process. This effect can be observed regarding the craterborders produced with SiC particles, as referred and showed above. Then, the wear resistance of the TiB₂ coating is six times higher for the SiC F1000 abrasive than SiC F1200.

4. Conclusions

After this work, some conclusion can be drawn, as following:

- \cdot Al₂O₃ abrasive particles shown low abrasivity, when compared with remaining abrasives tested. This can be attributed to its relatively low hardness and particles rounded contour.
- Micro-abrasion wear tests performed with diamond particles presented well-defined craters. Diamond shown high abrasivity. However, craters produced by SiC particles F1000 as well as F1200, are bigger than those formed by diamond particles;
- Heterogeneity of SiC particles used in this work, particularly SiC F1000, revealed to be harmful to micro-abrasion wear tests, resulting in ill-defined craters and lateral film detachments;
- The diameter of micro-abrasion wear craters and, consequently, the volume of material removed, allows to conclude that the hardness of the abrasive is very important but, there is not the only factor to contribute to severe micro-abrasion wear: when abrasive particles size increase, micro-abrasion wear is higher, not depending absolutely of the abrasive hardness;
- More accurate results can be achieved in micro-abrasion tests using, simultaneously, abrasives with high hardness and low grain size.

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